

OCT 04 2004

Practitioner's Docket No. MI22-2514

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: H. Daniel Dulman et al.

Application No.: 10/808,703
Filed: 03/24/04Group No.: 1756
Examiner: S.R. Mohamedulla

For: Methods of Forming Aligned Structures with Radiation-Sensitive Material


Commissioner for Patents
Washington, D.C. 20231

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(Certification of Facsimile Transmission--page 1 of 1)

OCT 04 2004

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 10/808,703
Filing Date March 24, 2004
Inventor H. Daniel Dulman et al.
Assignee Micron Technology, Inc.
Group Art Unit 1756
Examiner S.R. Mohamedulla
Attorney's Docket No. MI22-2514
Title: Methods of Forming Aligned Structures With Radiation-Sensitive Material

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

References - - See attached Form PTO-1449

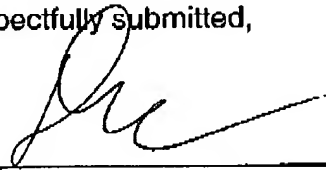
In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, your attention is directed to the United States patents listed on the attached Form PTO-1449. Copies of the cited art are not included, only U. S. patents are cited (1276 Off. Gaz. Pat. Off., 05 August 2003). No admission is made regarding whether all the submitted references are prior art.

Please charge the fee specified under 37 C.F.R. §1.17(p) to Deposit Account No. 23-0925. Please credit Deposit Account No. 23-0925 with any overpayment of the above fee.

Citation of these references is respectfully requested.

Respectfully submitted,

Date: 10/6/04



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Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. M122-2514		SERIAL NO. 10/808,703	
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT H. Daniel Dufman et al.			
				FILING DATE 03/14/04		GROUP 1756	
U.S. PATENT DOCUMENTS							
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	AA	6,312,854 B1	11/01	Chen et al.			
	AB	6,465,138 B1	10/02	Stanton			
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
	AL						
FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Subclass	Translation
							Yes No
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OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)							
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